



PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/696,432 Confirmation No. 6825
Applicant : Ying-Lang Wang
Filed : October 29, 2003
TC/A.U. : 2813

Title : **CMP Process Leaving No Residual Oxide Layer or Slurry Particles**

Docket No. : N1085-90131 (TS01-167CB)
Customer No. : 08933

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING,
37 C.F.R. §1.8(a)**

I certify that this correspondence and the enclosures mentioned therein are being deposited by First Class U.S. Mail with sufficient postage on the date shown below, addressed to Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450.

Richard A. Paikoff
Richard A. Paikoff, Reg. No. 34,892
10/18/05
Date

AMENDMENT AND RESPONSE UNDER 37 CFR 1.116(a)

Sir:

In response to the Office Action of July 11, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.